



Inventor: Garry A. Mercaldi
Title: Low Selectivity Deposition Methods
Assignee: Micron Technology, Inc.
Serial No.: 09/643,004
Filing Date: August 21, 2000
Docket No. MI22-1358


INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to the U.S. Patents and other documents listed on the attached Form PTO-1449, and copies of which are attached. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 20 Jul 2004

Attorney: 
James E. Lake
Reg. No. 44,854

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1358		SERIAL NO. 09/643,004		
		APPLICANT Garry Mercaldi				
		FILING DATE August 21, 2000		GROUP 2812		
U.S. PATENT DOCUMENTS						
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,458,416	10/2002	Derderian		
	AB	5,597,609	01/1997	Beisswenger et al		
	AC	5,290,824	09/2001	Ishikawa et al		
	AD	6,358,377	03/2002	Schloremberg et al		
	AE	6,627,260	09/2003	Derderian et al		
	AF	5,937,300	08/1999	Sekine et al		
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date	Country	Class	Subclasses	Translation
						Yes No
	AM					
	AN					
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)						
	AO					
	AP					
	AQ					
	AR					
EXAMINER			DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						

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